

## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Vignina 22313-1450 www.uspto.gov

## \*BIBDATASHEET\*

Bib Data Sheet

**CONFIRMATION NO. 8349** 

<b>SERIAL NUMBI</b> 10/542,873	07/00/0005		(	CLASS 324		GROUP ART UNIT 2829		ATTORNEY DOCKET NO. 5731-000014/US/NP	
APPLICANTS Beng Ghee Tan, Singapore, SINGAPORE;  ** CONTINUING DATA ******************* This application is a 371 of PCT/SG03/00022 02/05/2003  ** FOREIGN APPLICATIONS ************************************									
Foreign Priority claimed  yes no  35 USC 119 (a-d) conditions  yes no Met after met  Allowance  Verified and Acknowledged Examiner's Signature Initials				STATE OR COUNTRY SINGAPORE			TOT. CLAI 17	MS	INDEPENDENT CLAIMS 2
ADDRESS 28997 TITLE Method for detecti	ing and r	monitoring wafer pr	obing pro	ocess instabilit	y				
FILING FEE F	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:					☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			